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Patent  
Attorney Docket No. 51906 (ACT-111) // 7/03  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
David W. SHERMER et al ) Group Art Unit: 1772  
Application No: 09/519,165 ) Examiner: W. P. Watkins, III  
Filed: March 6, 2000 ) Confirmation No: 8879  
FOR: SINGLE MASK LITHOGRAPHIC )  
PROCESS FOR PATTERNING )  
MULTIPLE TYPES OF SURFACE )  
FEATURES )

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TC 1700  
Nov 07 2003

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Official Action issued July 31, 2003, applicants submit the following amendments and remarks.

**Amendments to the claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.